Bridging the Pressure Gap in Surface Science at the Atomic Level: H/Cu(110)

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The structural response of the Cu(110) surface to H_2 gas pressures ranging from 10^{-13} to 1 bar is studied using a novel high-pressure scanning tunneling microscope (HP-STM). We find that at H_2 pressures larger than 2 mbar the Cu(110) surface reconstructs into the (1×2) "missing-row" structure. From a quantitative analysis of the pressure dependence of the surface reconstruction, we conclude that Cu(110) responds identically to hydrogen at ultrahigh vacuum conditions and at atmospheric pressures. From the HP-STM data, we extract refined values for the adsorption and desorption rate constants.

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Surface science studies on single crystal model systems performed under idealized conditions, i.e., ultrahigh vacuum (UHV) and moderate temperatures, have contributed substantially to our present understanding of the elementary mechanisms governing gas-surface reactions and thereby the technologically important area of heterogeneous catalysis [1,2]. In a few cases it has even been demonstrated that new catalysts, operating at technologically relevant conditions, can be designed on the basis of such fundamental surface science insight [3,4]. It is therefore of utmost importance to clarify whether it is, in general, legitimate to extrapolate results obtained under such rarefied UHV conditions to high pressures and temperatures [5]. It is paramount to bridge this so-called pressure gap and to determine the structural response of surfaces to high pressures since the rates of reactions occurring on surfaces are strongly affected by surface morphology [1,2,6,7]. Recent efforts in this area include, e.g., the initial oxidation of Ru(0001) [8]. In the past it has been argued that surface and overlayer structures formed at low temperatures and UHV pressures can be very different from structures that might be thermodynamically stable only at high pressures and temperatures [9,10]. However, no *direct* imaging of the actual surface structure at atmosperic pressures at the genuine atomic level has been reported. Thus quantitative information about the response of metal surfaces to high pressures is so far lacking.

In this Letter, we present experimental results for the adsorption of hydrogen on Cu(110) and demonstrate the possibility of bridging the pressure gap in surface science at the atomic level. The H/Cu system is a classical model system for activated dissociative chemisorption [11–13] and it is important from a technological viewpoint in both the methanol synthesis [14] and the water-gas shift reaction [6,15]. In situ, atom-by-atom imaging of a metal surface structure, and the accompanying adsorbate-induced reconstruction, in equilibrium with the gas phase at pressures up to 1 bar at room temperature, is for the first time demonstrated. A detailed comparison with previous UHV studies reveals that the Cu(110) surface responds identically to hydrogen at UHV pressures and at atmospheric pressures. From the high-pressure scanning tunneling microscope (HP-STM) data we derive quantitative values for the rate constants for adsorption and desorption that considerably improve on previously reported UHV values.

The experiments were performed in a UHV chamber equipped with a new, novel STM design, which is implemented in a high-pressure (HP) cell attached to the main UHV chamber [16]. To ensure chemical inertness, the HP cell and all metal parts of the HP-STM are electrochemically gold plated. A dedicated gas handling system was constructed in which the H_2 was thoroughly cleaned by passing it through a catalyst bed $(Cu/ZnO/Al_2O_3)$ and a molecular sieve. The gas cleanliness is crucial due to the small sticking coefficient of H₂ on Cu ($s = 3.4 \times 10^{-11}$) at $T = 298$ K [13]), which means that if even minute amounts of impurities (such as CO or O_2) were present in the gas, they would dominate the adsorption. In fact, experiments were performed with 99.9997% purity H_2 gas used as delivered, and nanosized patches of impurities could immediately be detected to build up on the surface by atom-resolved STM. At the beginning of exposure, the impurity level was too low to be detected by conventional techniques such as Auger electron spectroscopy (AES) and low-energy electron diffraction (LEED). Although STM has limited chemical specificity, the ability of the STM to locally image surfaces with atomic resolution gives an unprecedented sensitivity with respect to judging the surface to be atomically clean or not, and the present study certainly demonstrates the necessity of high gas purity when performing high-pressure studies. The Cu(110) crystal was cleaned by standard procedures (800 eV Ar ion sputtering followed by annealing to 820 K), until the sample was clean and well ordered as determined by STM, AES, and LEED. All STM measurements were performed at $T = 298$ K.

Figure 1 depicts a sequence of STM images of the Cu(110) surface obtained before H_2 exposure (A), at an ambient H_2 pressure of 1 bar (B), and finally after subsequent evacuation of the HP cell (C). It is apparent that upon H_2 exposure at 1 bar the surface reconstructs into the well-known (1×2) missing-row structure with every second close-packed $\lceil 110 \rceil$ Cu row expelled $\lceil 17-20 \rceil$. After evacuation of the HP cell, the surface reconstruction is

FIG. 1 (color). A sequence of atom-resolved STM images recorded at $T = 298$ K in the HP-STM depicting the Cu(110) surface (A) *before* H₂ exposure ($I = 1.42$ nA; $V = 105$ mV), (B) *during* exposure to 1 bar of H₂ (the image is recorded 1 h 50 min after exposure ($I = 1.55$ nA; $V = 29.3$ mV), and (C) after a time lapse of ~ 1500 s directly *after* evacuating the HP cell ($I = 1.06$ nA; $V = -4.9$ mV). The unit cell of the (1 \times 2) missing-row structure is indicated in (B) (2.55 \times 7.22 Å²). All figures are drawn on the same scale $(46 \times 45 \text{ Å}^2)$.

lifted and only a (1×1) surface structure is observed. This implies that during the time between evacuation of the HP cell and resumption of imaging $(\sim 1500 \text{ s})$, sufficient hydrogen must have been depleted from the surface for the reconstruction to lift. Subsequent AES and STM showed that no impurities were present on the surface after the high-pressure treatment.

In order to investigate the pressure dependence of the H-induced reconstruction, STM imaging was performed at a range of different H_2 pressures between UHV and 1 bar (marked with arrows in Fig. 2). Figures 2A and 2B show two STM images obtained at 2 and 20 mbar H_2 , respectively [21]. At 2 mbar only a (1×1) structure is observed, while at 20 mbar the surface consists of large areas $(>100 \times 100 \text{ Å}^2)$ displaying the (1 × 2) reconstruction, as well as (1×1) domains (Fig. 2B inset). This means that (1×2) nuclei formation starts somewhere between 2 and 20 mbar (light grey area in Fig. 2C). The sole observation of the bare Cu lattice at 2 mbar (Fig. 2A)—even after hours of exposure—provides a direct proof that we have well-defined conditions with no impurities present in the gas, since practically all molecules have higher sticking probability on Cu than H_2 . At 20 mbar atom-resolved imaging could be obtained only on the nonrestructured surface, i.e., on (1×1) domains (in Fig. 2B inset). In regions where the (1×2) phase had nucleated, protruding domains, which were not stable over time, as well as deeper layers (dark regions), were also observed. The former protrusions ("disordered" structure in Fig. 2B) are probably due to rapidly diffusing Cu atoms [22] that are present on the surface during the formation of the (1×2) phase and which interfere with the measurements. In these experiments Ar was additionally admitted to the HP cell so that for all H_2 partial pressures the total pressure was always 1 bar. This is necessary to avoid discharging between the piezoelectric scanner tube electrodes of the STM in the 10^{-3} to 10 mbar regime.

The binding state of the adsorbed H was determined by postexposure temperature-programmed desorption (TPD). Figure 3B shows a TPD spectrum after 15 min exposure at 1 bar, recorded after a delay time between exposure and the TPD experiment of 1200 s. The TPD spectrum is characterized by a small peak at $T = 340$ K. This is interpreted as H_2 originating from H adsorbed on the Cu(110) surface, consistent with previous studies [12,23]. The amount of H_2 was calibrated by comparing with TPD spectra obtained from a saturated Cu(110)-(1 \times 2)-H structure prepared in UHV by exposing the surface to atomic H formed by predissociation on a hot tungsten filament. The surface prepared in this manner is characterized by a sharp (1×2) LEED pattern and a TPD peak at $T = 345$ K and is known to saturate at a coverage of 1 H atom per (1×2) surface unit cell, i.e., at a saturation coverage of $\theta_{\text{sat}} = 0.5$ [19] (see Fig. 3A). Using this latter TPD peak as a reference, the amount of surface H in Fig. 3B is determined to be $\theta = 0.10 \pm 0.02$. The low surface coverage of H in these TPD experiments can easily be accounted for by desorption occurring during evacuation and transfer to UHV prior to TPD when the sample is held at room temperature. By varying the time between evacuation and TPD the H desorption rate constant is determined to be $k_d = (1.2 \pm 0.1) \times 10^{-3} \text{ s}^{-1}.$

A large database of UHV studies of the $H/Cu(110)$ system exists [12,13,17–20,23], which allows us to scrutinize the validity of the "surface science approach" to predict corresponding high-pressure phenomena. Briefly, these studies have shown that chemisorption of H on the Cu(110) surface induces the (1×2) missing-row reconstruction at $T > 140$ K [17,18]. Experiments have shown that small (1×2) nuclei form already at low hydrogen coverages $(\theta_H \ge 0.05)$ [18–20]. The transformation from the reconstructed (1×2) to the nonreconstructed (1×1) surface at $T > 250$ K has also been studied and the rate constant for desorption determined [18,19]. The desorption is found to be of first order suggesting that the ratedetermining step is associated with restructuring of the surface rather than associative H_2 desorption. The high activation barrier for H adsorption limits the H uptake onto the Cu surface. Therefore conventional UHV studies of molecular hydrogen adsorption have primarily been

FIG. 2. (A) STM image depicting the (1×1) surface structure at P_{H_2} = 2 mbar (57 \times 47 Å²), and (B) the mixed (1 \times 2) and (1×1) surface structures at $P_{\text{H}_2} = 20$ mbar $(221 \times 178 \text{ Å}^2)$. The latter structure is shown with atomic resolution in the inset in (B) (40 \times 40 Å²). Patches of "disordered," protruding regions (bright color) and holes in the lattice (dark color), respectively, are visible on the surface where the (1×2) restructuring occurs. (C) Pressure dependence of the $(1 \times 1) \rightarrow (1 \times 2)$ H-induced reconstruction at $T = 298$ K. The arrows at the top abscissa show the different pressures at which HP-STM imaging was performed. The light grey area shows the pressure regime in which the (1×2) reconstruction occurs. The region enclosed by the thin solid lines marks the lower and upper limits of the equilibrium coverage vs pressure as deduced from the HP-STM measurements. The equilibrium coverage is from the TH-3 LM measurements. The equinorium coverage is
given by $\theta_{eq} = \frac{1}{2} + \alpha - \sqrt{\alpha(\alpha + 1)}$, where $\alpha = k_d/4k_aP_{H_2}$. The horizontal dashed line indicates the low coverage limit $(\theta \ge 0.05)$ for (1×2) nucleation, as determined from UHV studies. The curved dashed line shows the adsorption isotherm obtinaed using available UHV data (see text). Finally, the dark grey region indicates the combined high pressure and UHV limits where the surface reconstruction occurs.

done by means of molecular beam techniques, where the energy of the impinging molecules can be raised to overcome the activation barrier for adsorption [11,12,24]. However, in these latter cases no systematic study of the surface structure has been reported, although TPD

FIG. 3. TPD spectra showing the H₂ desorption, $m/Z = 2$. (A) Spectrum from a saturated Cu(110) ($\theta_H = 0.5$) surface prepared by adsorption of atomic H in UHV at $T = 220$ K and (B) from the Cu(110) surface after 15 min exposure to 1 bar of H_2 at $T = 298$ K. The latter spectrum is recorded after a time lapse of 1200 s between evacuation of the HP cell and transfer to UHV. The heating rate was $2 K/s$.

measurements indicate that the H binding state is similar to the corresponding atomic H case [12]. In one case, high-pressure exposure has been used to compensate for the low sticking probability. In this latter study, the adsorption of a Boltzmann distributed H_2 gas was studied in the range $T = 470 - 720$ K by reactive "titration" experiments with preadsorbed oxygen, from which the H² sticking probability and the activation barrier for adsorption were deduced [13].

We may in a very direct way compare the rate constants for adsorption, k_a , and desorption, k_d , derived from previous UHV studies quoted above, with the high-pressure STM data. Neglecting the rate of diffusion into the bulk, which is small [25], the kinetic equation describing the adsorption and desorption is given by

$$
\frac{d\theta}{dt} = 2K_a P_{\rm H_2} \left(1 - \frac{\theta}{\theta_{\rm sat}}\right)^2 - k_d \theta \,. \tag{1}
$$

Here K_a is the normalized rate constant for adsorption $(K_a = k_a/4$ if $\theta_{sat} = 0.5)$. As discussed above, the HP-STM data provide a narrow window $(2 \le P_{\text{H}_{2}}$ < 20 mbar) for the onset of the (1×2) reconstruction as a function of H_2 pressure (light grey region in Fig. 2). UHV data indicate that (1×2) nuclei formation starts at $\theta \ge 0.05$ [18–20] (horizontal dashed line in Fig. 2C). Furthermore, using Eq. (1), this implies that the H equilibrium coverage must be $\theta_{\text{eq}} \leq 0.05$ at $P_{\text{H}_2} = 2$ mbar, and $0.05 \le \theta_{\text{eq}} < 0.21$ at $P_{\text{H}_2} = 20$ mbar, or equivalently $4.1 \times 10^{-3} / P_{\text{H}_2}[\text{bar}] < \alpha < 4.1 \times 10^{-2} / P_{\text{H}_2}[\text{bar}]$, where $\alpha = k_d/4k_aP_{\text{H}_2}$. Inserting these limits, we obtain the

region enclosed by the thin solid lines in Fig. 2C. This reduces the region in pressure-coverage space where the (1×2) reconstruction occurs to the dark grey region in Fig. 2C. The HP-STM data reported here considerably narrow down the uncertainty in α (or k_d/k_a). Using the value for k_d determined from the post-TPD measurements we find that $7.3 \times 10^{-3} < k_a < 7.3 \times 10^{-2} \text{ s}^{-1} \text{ bar}^{-1}$, which is in good agreement with previously reported values for $k_a = 3.4 \times 10^{-2} \text{ s}^{-1} \text{ bar}^{-1}$ [13]. Scrutinizing the rate constants for desorption reported from UHV studies, which show significant spread [12,18,19], we find the best agreement with $k_d = 6.6 \times 10^{-4} \text{ s}^{-1}$ [19], which is consistent with the α limits imposed by the HP-STM data and the reported k_a values. In Fig. 2C is shown the adsorption isotherm using this latter value of k_d (curved dashed line). It is clear that the UHV data show remarkably good agreement with the high-pressure data reported here.

In conclusion, we have bridged the pressure gap at the ultimate resolution, i.e., on an atom-by-atom basis. By the use of a novel high-pressure STM, we have shown that for the chosen system, $H/Cu(110)$, the surface reconstructs into the (1×2) missing-row structure at H₂ partial pressures \geq 2 mbar and thus responds identically to a reactive gas at UHV and atmospheric pressures. The results imply that raising the pressure is equivalent to lowering the temperature, which is usually what is done in UHV studies in order to study high surface coverage structures. The HP results are in excellent agreement with available UHV data. The latter is important since it constitutes the basis for numerous well-characterized and well-controlled UHV studies aimed at elucidating related gas-surface reactions, even at "real" reaction conditions, and it provides support for the surface science approach.

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